



DFW

IOAP 4.1-1
Appl. No. 10/526,800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/526,800 Confirmation No. 7409
Applicant: Anatoly Leontievich Vikharev et al.
Title: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND
FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE
PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD
Filed: March 7, 2005
TC/A.U.: 1792
Examiner: Rakesh Kumar Dhingra
Docket No.: IOAP 4.1-1 (000141527-0001)
Customer No: 35684

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INTERVIEW SUMMARY

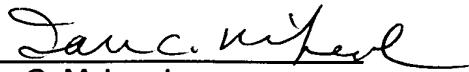
Sir:

As a result of a telephone call from Examiner Rakesh Dhingra, Claims 7, 8 and 14 were allowed. Attached is Claim 7 with the Amendment set forth in the Examiners Amendment. To further clarify the Examiners Amendment

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to Claim 7, on line 9 (of the attached claim) the words "at least" have been underlined.

Respectfully,


Ian C. McLeod
Registration No. 20,931

BUTZEL LONG
2190 Commons Parkway
Okemos, Michigan 48864

Telephone: (517) 347-4100
Facsimile: (517) 347-4103
Email: taylorl@butzel.com